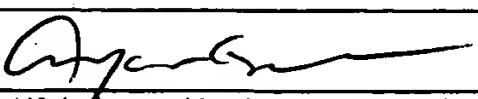


First Named Inventor	Kevin G. Donohoe	INFORMATION DISCLOSURE STATEMENT FORM PTO-1449
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Title: ETCHING OF HIGH ASPECT RATIO STRUCTURES		Sheet 1 of 1

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Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
IA	6,451,705B1	09/17/02	Trapp et al.	08/31/02
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Foreign Patent References					
Examiner Initials	Foreign Patent		Name	Publication Date	Translation
	Country	No.			

Other References		
Examiner Initials	Author, Title, Date, Pages, etc.	

Examiner Signature		Date Considered	8/21/04
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*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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